

Materials Research Facility

Monica Jong; Steven Van Boxel; Martin O'Brien; Otto Caretta







- Introduction
- MRF current facility and capabilities
- Plan for facility extension
- Examples of materials research at MRF





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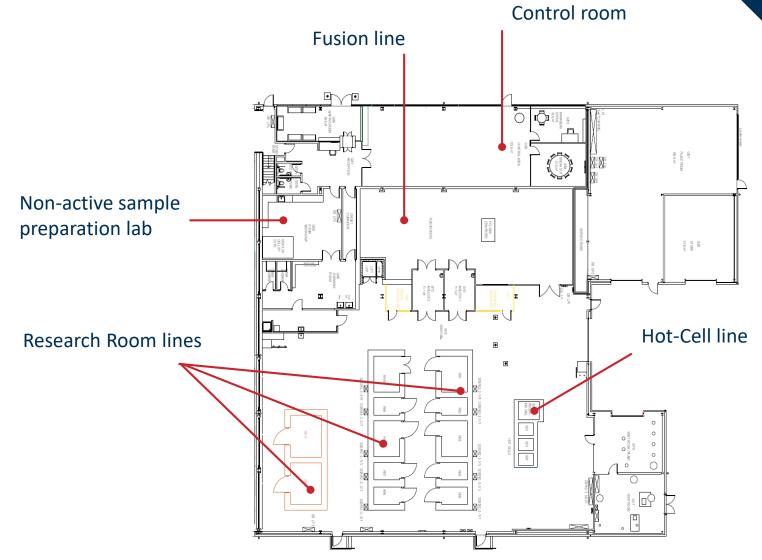


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UKAEA MRF hot-cell line

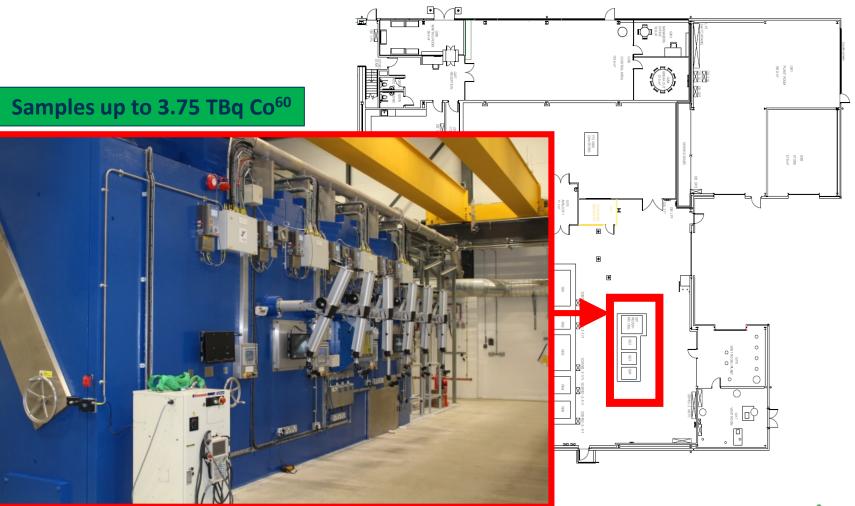






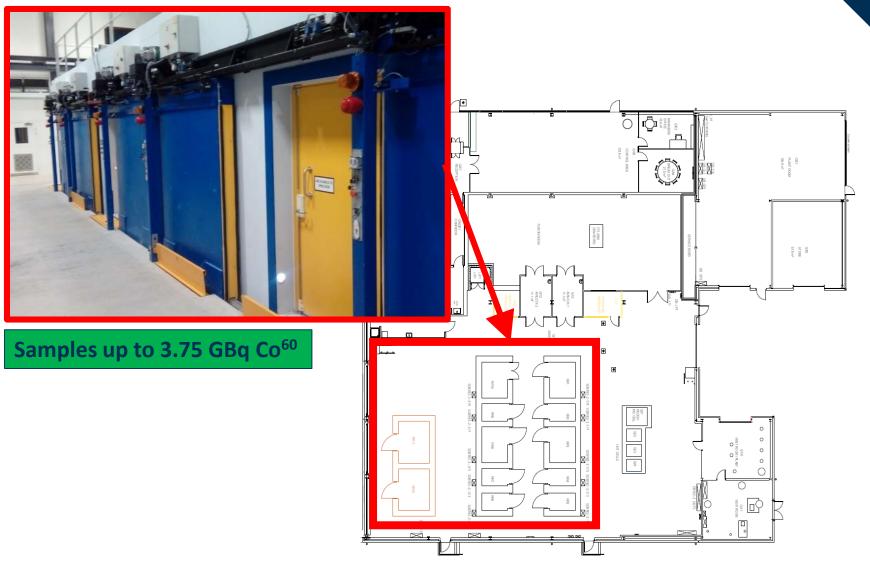
UKAEA MRF hot-cell line





UKAEA MRF Research Rooms







UKAEA MRF glovebox line









GAZ STORE 578 m²



UKAEA MRF Control room





Instrument integration in active area













UKAEA-MRF: Sample Preparation

UK Atomic Energy Authority

Non active Sample prep lab

Cutting, grinding, polishing

Electro polishing

Optical microscopy

Non active sputter coater

PIPS-II ion polisher

Lab scale EDM

3mm disc punch

3 zone tube furnace 1200°C

Dimple grinder

Active sputter coater

Hot-cell lab-scale EDM

Glovebox cutting, grinding, polishing



Note:

Currently available

To be commissioned 2019/20



UKAEA-MRF: Microstructural Characterisation



FEGSEM

Tescan Mira XH EDX, EBSD, TKD, WDS

Dual beam FIB

FEI Helios

GIS: Pt, W, C

Nano-manipulator for sample lift-out

AFM

Veeco D3100

PMI XRF

Olympus delta premium PMI XRF

Scanning Confocal Raman Microscope

AFM

In-situ (e.g. Heating, liquid, & gas)

XRD goniometer

High brilliance X-ray source



Note:

Currently available

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UKAEA-MRF: Thermo-physical Analysis



Thermal Desorption Spectroscopy

Hiden TPD workstation Up to 1000°C

Gas Impregnation Technique

Ar, N_2 , Air, He, D_2 , Tritium Ion energy < 500 eV, RT – 500°C

Dilatometer

Linseis L75V, dual pushrod -150°C – 600°C and RT – 2000°C

Laser Flash Analyser

Linseis LFA 1000 -100°C – 500°C and RT – 2000°C

TGA/DSC

Linseis STA PT1600 -150 $^{\circ}$ C - 500 $^{\circ}$ C and RT - 1600 $^{\circ}$ C

Gas pycnometry



Note:

Currently available
To be commissioned 2019/20



UKAEA-MRF: Mechanical Testing

UK Atomic Energy Authority

Nanoindenter Agilent G200

Static load frame 10 kN
Shimadzu AGS-x
Environmental chamber for up to 800°C

Dynamic load frame 15 kN

TA Electroforce 3500

Environmental chamber for up to 800°C

Small-punch testing

Vacuum chamber with induction heating

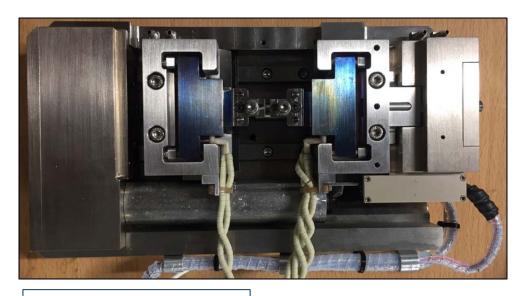
In-situ SEM load frame 5 kN
DEBEN MTEST
Clamp heating up to 600°C

Instrumented indenter

UltraSonic Fatigue Setup

DIC strain measuring system Impulse excitation testing





Note: Currently available To be commissioned 2019/20



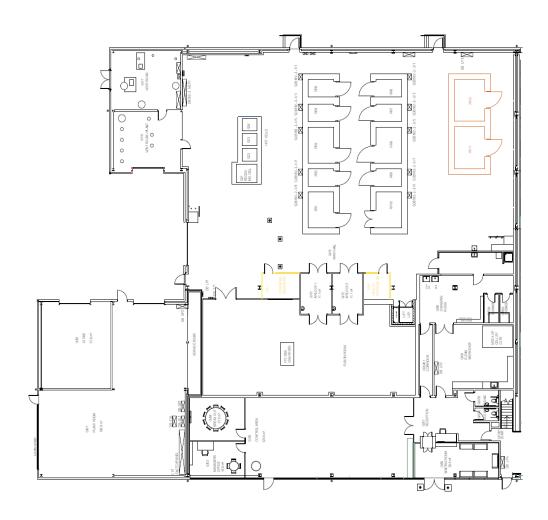


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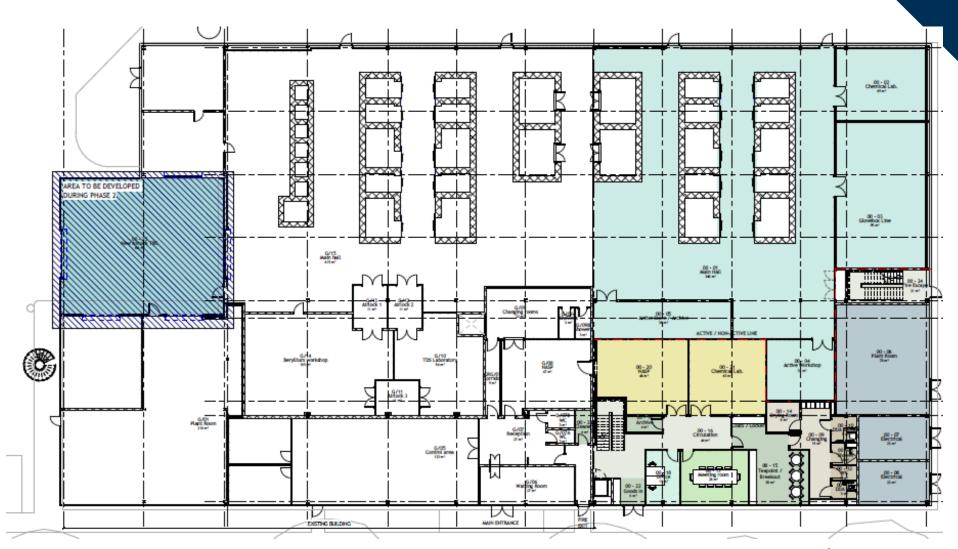






Building extension plans

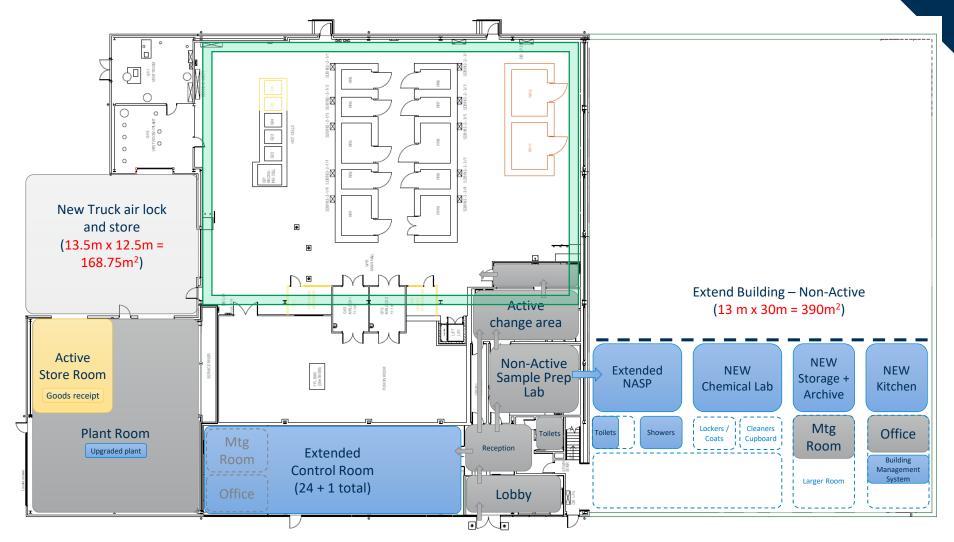






MRF Summary - Non-Active (operations)

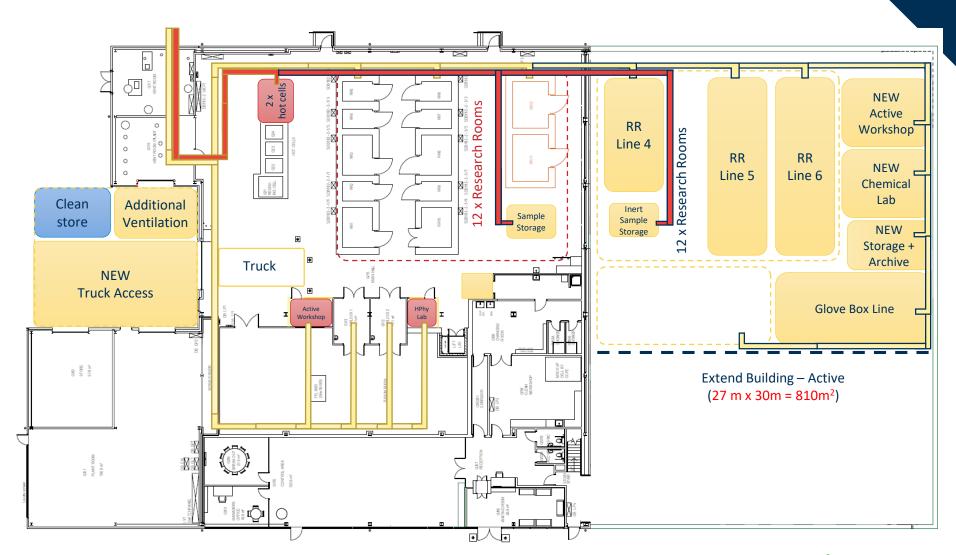






MRF Summary - Active









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Relevant Expertise at the UKAEA-MRF



Sample preparation

FIB machining on all fusion relevant metals, expertise with low activity samples TEM sample prep with FIB and PIPS on low activity materials, currently working towards electropolishing on active materials

Micromechanical testing

Nano-indentation, size effects

Different indenter geometries (Berkovich, Cube, Spherical, ...)

Post indentation AFM analysis of pile up and indenter contact area

Post indentation cross sectional analysis with SEM-TKD and TEM for plastic zone size determination

Micro-cantilever bending tests

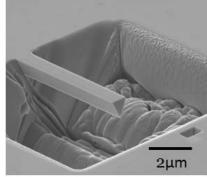
Nano indentation at RT, high T is top priority for future investment programs (18/19 onwards)

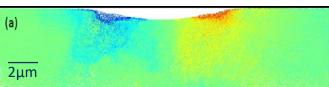
Microstructural Analysis

TEM, SEM, Raman imaging, XRD, etc..

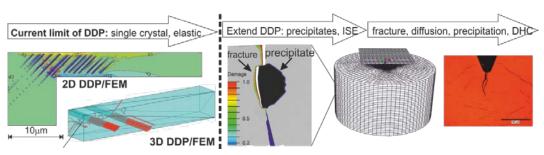
Through collaborations

- APT (Oxford)
- Chemi-STEM (Manchester)
- Materials modelling at various length scales (CCFE, Imperial, Oxford)





Strain mapping using Transmission Kikuchi Diffraction (TKD) techniques on indentation crosssection (first of its kind)



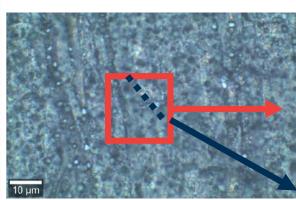


Advanced Laser Scanning Confocal Raman Microscope (LSCRM)

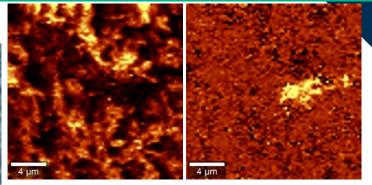




Liquid & gas heating stage (up to 1300°C)



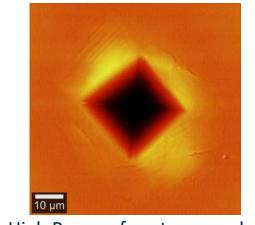
Optical Micrograph of Alloy 625



Raman SI (Comp. 1) Raman SI (Comp. 2)



3D depth Raman signal profile of the oxides



High Res. surface topography of a nano-indent on a Cu-alloy

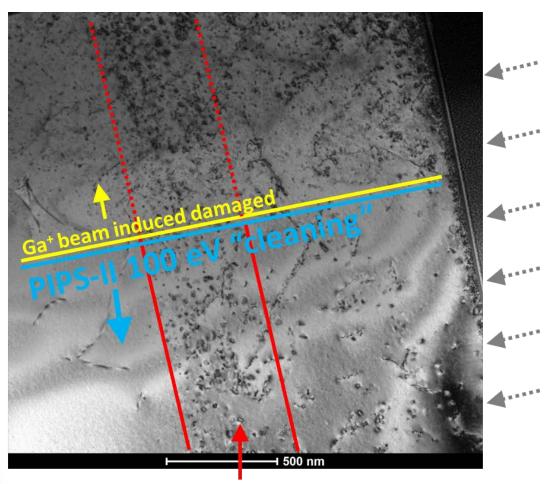
- High resolution 3D Raman imaging capability
- In-situ Raman imaging capability (at temperature, liquid and gas)



TEM Specimen preparation using ion beams (FIB & PIPS-II)







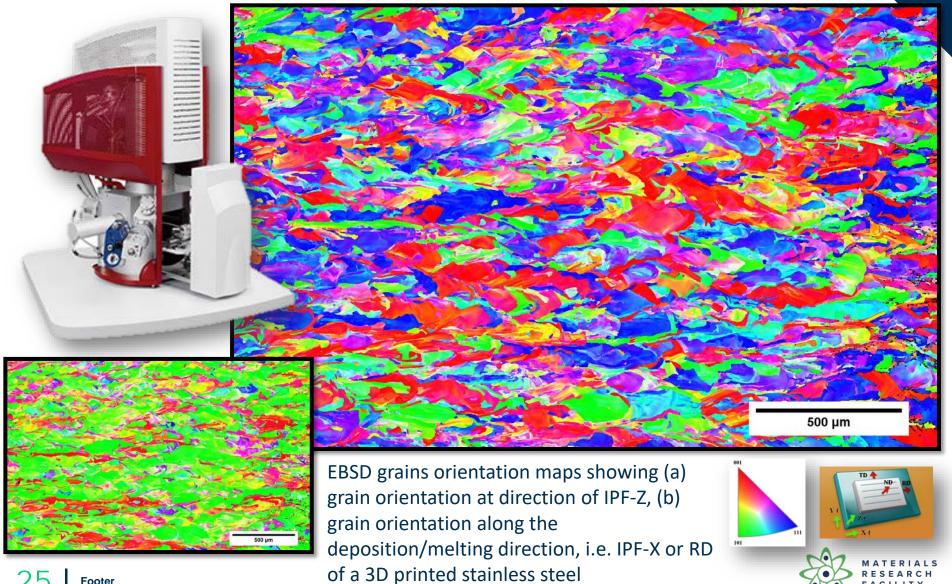
lons Implantation direction

5MeV Fe²⁺ induced damage (Bragg Peak)



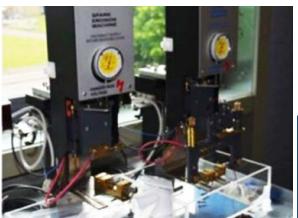
Large area EBSD mapping using SEM





IMPACT OF FABRICATION TECHNIQUES ON SMALL SAMPLE GEOMETRIES





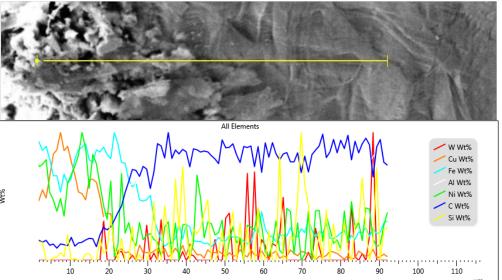
Cutting effect evaluation:

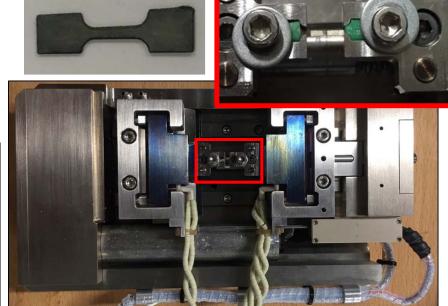
Technique comparison to qualify the lab-scale EDM (Electric Discharge Machining) samples (0.3 mm thick SS 316L) against Wire EDM cutting / Photo chemical etching / Laser cutting using tensile samples.



Tensile test & fracture surface evaluation:

GL = 5x1x0.3 mm





With thanks to **Abineeth Singh** (3 months summer student placement 2018; MsC Advanced Nuclear Engineering; Imperial College London

